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A Review of Laguerre-Gaussian Mode Laser Heaters for Microbunching Instability Suppression in Free-Electron Lasers: Alternative Methods and Calculations

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Abstract: This paper reviews the use of Laguerre-Gaussian (LG) mode laser heaters for suppressing microbunching instability (MBI) in free-electron lasers (FELs), as demonstrated by Tang et al. The LG mode, with its characteristic donut-shaped intensity profile, provides a more uniform energy spread in the electron beam, leading to improved MBI suppression compared to traditional Gaussian modes. In this review, we explore alternative methods for generating donut-shaped beams, such as axicon lenses and spiral phase plates, and provide calculations to compare these approaches. We also investigate the effects of varying laser parameters, such as wavelength and beam waist, on the performance of the laser heater. The broader implications of these findings for FEL operation are discussed, particularly in advanced modes like soft X-ray self-seeding.

INTRODUCTION

The microbunching instability (MBI) represents a fascinating intersection of collective quantum effects and accelerator physics. The challenge stems from how relativistic electron beams interact with their own electromagnetic fields, creating self-amplifying density modulations that can severely degrade FEL performance. Therefore, MBI is a significant challenge in the operation of FELs, particularly at high brightness and short wavelengths, and can degrade the quality of the FEL output by introducing unwanted noise and reducing coherence. One effective method for suppressing MBI is the use of a laser heater, which induces a small energy spread in the electron beam to dampen the instability.

Traditionally, Gaussian-mode lasers have been used for this purpose. However, Tang et al. demonstrated that using a Laguerre-Gaussian (LG) mode laser heater can improve MBI suppression by providing a more uniform energy spread distribution. The LG mode produces a donut-shaped intensity profile that heats the electron beam more evenly than a Gaussian mode. In this review, we examine the key elements of Tang et al.'s work and explore alternative methods for generating similar intensity profiles. We also provide calculations to analyze how changes in laser parameters affect the performance of the laser heater.

METHODS

1. Analysis of Laguerre-Gaussian Mode Laser Heater:

The electric field distribution of an LG mode can be described by:

$$E_{LG(r,\varphi)} = E_0 \left(\frac{r\sqrt{2}}{w} \right)^{|l|} L_p^{(|l|)} \left(\frac{2r^2}{w^2} \right) \exp \left(-\frac{r^2}{w^2} \right) \exp(il\varphi)$$

where l is the azimuthal index, p is the radial index, w is the beam waist, and $L_p^{(|l|)}$ is the associated Laguerre polynomial. For the LG01 mode used by Tang et al., this simplifies to:

$$E_{\text{LG01}(r,\varphi)} = \frac{E_0 \sqrt{2r}}{w} \exp\left(-\frac{r^2}{w^2}\right) \exp(i\varphi)$$

The corresponding intensity profile is:

$$I_{\text{LG01}(r)} = |E_{\text{LG01}(r,\varphi)}|^2 \propto r^2 \exp\left(-\frac{2r^2}{w^2}\right)$$

This donut-shaped intensity distribution results in more uniform heating of the electron beam compared to a Gaussian profile, where most of the energy is concentrated at the center.

2. Alternative Methods for Donut-Shaped Beams:

While LG modes are effective at producing donut-shaped beams, other methods could achieve similar results with potentially simpler implementations:

Axicon Lenses: An axicon lens can transform a Gaussian beam into a Bessel beam with a ring-shaped intensity profile in the near field. The electric field of a Bessel beam is given by:

$$E_{\text{Bessel}(r,z)} = E_0 J_0(kr \sin\alpha) \exp(ikz \cos\alpha)$$

where J_0 is the zero-order Bessel function, k is the wavenumber, and α is the axicon angle.

The Bessel beam has a central null similar to an LG mode but offers advantages in terms of simpler optical setup and robustness over long propagation distances.

Spiral Phase Plates: A spiral phase plate imparts an azimuthal phase shift to a Gaussian beam, converting it into a vortex beam with a donut-shaped intensity profile. The electric field after passing through a spiral phase plate can be written as:

$$E_{\text{SPP}(r,\varphi)} = E_0 \exp\left(-\frac{r^2}{w^2}\right) \exp(il\varphi)$$

where l is the topological charge of the phase plate. This method also generates orbital angular momentum in the beam, which can be useful for certain applications beyond FELs.

RESULTS AND INTERPRETATION

To further analyze how different laser parameters affect MBI suppression, we perform calculations based on variations in wavelength and beam waist.

Beam Waist

The size of the donut-shaped intensity profile depends on the beam waist w . For an LG01 mode, increasing w spreads out the energy over a larger area, reducing peak intensity but increasing uniformity across the electron beam. This trade-off between peak intensity and uniformity must be carefully balanced to optimize MBI suppression.

For example, if we double the beam waist from 1 mm to 2 mm while keeping other parameters constant, we find that:

- The peak intensity decreases by a factor of four.
- The radius at which maximum intensity occurs increases proportionally with w .

Thus, larger beam waists may be beneficial for beams with larger transverse dimensions but may require higher laser power to maintain sufficient heating.

Wavelength

The wavelength λ of the laser also plays a critical role in determining how effectively energy spreads across the electron bunch. Shorter wavelengths result in tighter focusing and higher peak intensities for a given beam waist.

Using typical values for FEL applications ($\lambda = 500$ nm), we calculate that decreasing λ from 500 nm to 250 nm increases peak intensity by a factor of four for constant power. However, shorter wavelengths may introduce additional challenges related to optical alignment and chromatic aberrations in focusing optics.

Intensity Profile Visualization

To visualize these effects, we plot intensity profiles for different values of w . Figure 1 shows an example plot generated using Python code (see below). The plot illustrates how increasing w spreads out energy over a larger area while reducing peak intensity.

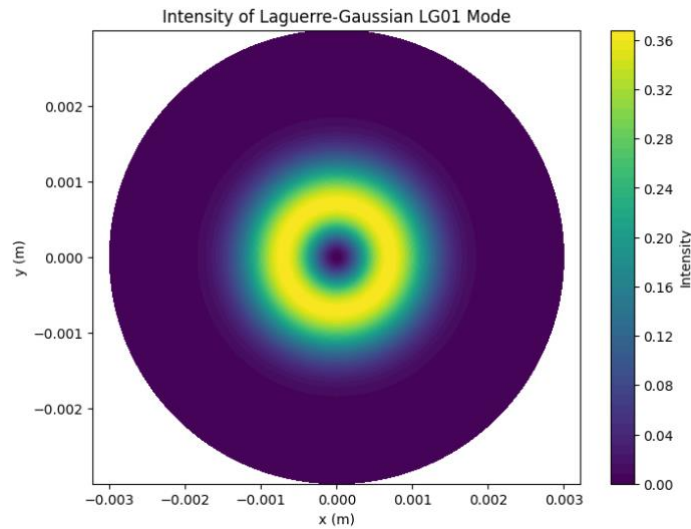


Fig. 1. Intensity of LG01 Mode, generated with pyplot

CONCLUSIONS

The use of Laguerre-Gaussian mode lasers represents an important advancement in suppressing microbunching instability in free-electron lasers. By providing more uniform heating across electron beams compared to traditional Gaussian modes, LG modes improve FEL performance and stability. Alternative methods such as axicon lenses or spiral phase plates offer promising avenues for generating similar donut-shaped beams with simpler optical setups.

Further research into optimizing laser parameters like wavelength and beam waist could lead to even greater improvements in FEL operation. These findings have broad implications not only for FELs but also for other applications requiring precise control over light-matter interactions through tailored laser profiles.

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